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	Application Number	10/623,375 (Patent No. 6,955,719)					
	Filing Date	07-18-2003					
	First Named Inventor	Vladimir Dmitriev					
	Title	Manufacturing Methods for Semicondu					
	Art Unit	1722					
	Examiner Name	SONG, MATTHEW J					
	Attorney Docket Number	TDI-008-US1					

I hereby revoke a	II previo	us powers of attorney gi	ven in the al	bove-ide	ntified applic	ation.				
I hereby appoint:										
✔ Practitioners as	sociated <sup>,</sup>	with the Customer Number:		234	¥10					
OR										
Practitioner(s) r	Practitioner(s) named below:									
		Name		Registration Number						
as my/our attorney(s) Trademark Office con		s) to prosecute the application erewith.	identified above	e, and to t	ransact all busir	ess in the U	nited States Patent and			
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Applicant/Inv	entor.									
		he entire interest. See 37 CFR	₹ 3.71.							
		FR 3.73(b) is enclosed. (Form								
SIGNATURE of Applicant or Assignee of Record										
Signature	[Please see signed document attached]				Date	January 17, 2007				
Name	Vladimir Dmitriev				Telephone					
Title and Company	Preside	nt, Technologies and Devices I	International, In	IC.						
NOTE: Signatures of all the inventors or assignees of record of the entire interest or their representative(s) are required. Submit multiple forms if more than one signature is required, see below*.										
*Total of		forms are submitted.								

This collection of information is required by 37 CFR 1.31, 1.32 and 1.33. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to take 3 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## POWER OF ATTORNEY (REVOCATION OF PRIOR POWERS) AND PROSECUTION BY ASSIGNEE UNDER 37 C.F.R. § 3.71

Sir:

TECHNOLOGIES AND DEVICES INTERNATIONAL, INC., the assignee of the entire right, title and interest of the patents and patent applications listed below, under 37 C.F.R. § 3.71 hereby revokes all powers of attorneys previously given in the below-identified patent applications and hereby appoints all attorneys associated with:

#### Customer Number

23410

PATENT TRADEMARK OFFICE

with full powers of substitution and revocation, to prosecute this application and transact all matters in the United States Patent and Trademark Office, and in countries other than the United States, and to do all things necessary or appropriate therefore before any competent International Authorities in connection with any international patent application(s) corresponding to the above-identified application, said appointment to be to the exclusion of the inventors and their attorneys in accordance with the provisions of 37 C.F.R. § 3.71.

#### Correspondence Address

Please change the correspondence address for the below-identified patent applications to the customer number 23410, and direct all written communications relative to such applications to:

Gary D. Lueck Vista IP Law Group LLP 2040 Main Street, 9<sup>th</sup> Floor Irvine, California 92614

Please direct all telephone communications to Gary D. Lueck at (714) 449-8433.

### **Patent Applications and Patents:**

Vista Docket No.	Title	Serial No.	Patent No.
		(Filing Date)	(Issue Date)
TDI-005-US1	Method and Apparatus for Fabricating Crack-Free Group III Nitride Semiconductor Materials	10/778,633	
	Seineondictor waterials	(2/13/04)	
TDI-005-US2.	Method and Apparatus for Fabricating Crack-Free Group III Nitride Semiconductor Materials	11/483,455	
	Semiconductor iviatorials	(7/10/06)	
TDI-006-US1	HVPE Apparatus For Simultaneously Producing Multiple Wafers During a Single Epitaxial Growth Run	11/173,039	
	Single Epitaxiai Growti Raii	(7/1/05)	
TDI-006-US2	Method for Simultaneously Producing Multiple Wafers During a Single Epitaxial Growth Run	11/173,193	
	Epitanai Giowai Kan	(7/1/05)	
TDI-007-US1	Method of Epitaxially Growing Device Structures With Sharp Layer Interfaces Utilizing HVPE	10/109,988	6,573,164
		(3/28/02)	(6/3/03)
TDJ-007-US2	Apparatus for Epitaxially Growing Semiconductor Device Structures With Sharp Layer Interfaces Using HVPE	10/113,222	
		(3/28/02)	
TDI-007-US3	Apparatus for Epitaxially Growing Semiconductor Device Structures With Submicron Group III Nitride Layer	10/109,317	6,706,119
	Utilizing HVPE	(3/28/02)	(3/16/04)
TDI-007-US4	Method of Epitaxially Growing Submicron Group III Nitride Layer Utilizing HVPE	10/112,277	6,656,272
		(3/28/02)	(12/2/03)
TDI-007-US5	Method of Epitaxially Growing Device Structures With Submicron Group III Nitride Layers Utilizing HVPE	10/113,692	6,660,083
		(3/28/02)	(12/9/03)
TDI-008-US1	Manufacturing Methods for Semiconductor Devices With Multiple III-V Material Layers	10/623,375	6,955,719
		(7/18/03)	(10/18/05)
TDI-011-US3	Reactor for Extended Growth Duration of Gallium Containing Single Crystals	10/632,736	
		(8/1/03)	

Power of Attorney Technologies and Devices International, Inc.

I, the undersigned, declare that I have reviewed copies of the documentary evidence establishing chain of title to the patent applications identified above from the inventor(s) to the assignee.

To the best of the undersigned's knowledge and belief, title is in the assignee identified above. Furthermore, the undersigned is empowered to sign this document on behalf of the assignee.

Dated: Jan. 17,07

TECHNOLOGIES AND DEVICES INTERNATIONAL, INC.

Name: AV alla

Title: President

Address: 12214 Plum Orchard Drive

Silver Spring, MD 20904